

 CYPR-PM01031

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Chang

Serial: 10/086,051

Group Art Unit: 2121

Filed: February 27, 2002

Examiner: Crystal J. Barnes

For: A METHOD AND SYSTEM FOR A REJECT MANAGEMENT
PROTOCOL WITHIN A BACK-END INTEGRATED CIRCUIT
MANUFACTURING PROCESS

AMENDMENTS and REMARKS

Honorable Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the non-final Office Action mailed June 17, 2005 in the
above captioned case, Applicants respectfully request the Examiner to enter the
following amendments and to consider the following remarks.